## PATENT NUMBER and ISSUE DATE

## U.S. **UTILITY** Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS 622	GAU 1 <del>775</del>	EXAMINER (			
10015063	12/11/2001					٦		
**APPLICANTS: Heath James, Collier Charles, Luo Yi, Deionno Erica; Beck Patricia;								
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**CONTINUING DATA VERIFIED:								
** FOREIGN APPLICATIONS VERIFIED:								
FOREIGN APPLICATIONS VENTILE.								
PG-PUB DO I	NOT PUBLISH		RESCI	ND 🗆				
Foreign priority cla 35 USC 119 cond		,	s ⊒ no s ⊒ no		ATTORNEY DOCKET NO			
Venfied and Acknowledged Examiners's initials 0180,0001								
TITLE: Method for lithographic processing on molecular monolayer and multilayer thin films								
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	sistant Examiner	Total Claims	Pris O.G	nt Claim for		
ISSUE FEE		DRAWING				
Amount Due Date Paid		Sheets Drwg.	Figs.Drwg.	Print Fig.		
	Primary Examiner			1		
TERMINAL	PREPARED FOR ISSUE	Application Examiner				
Um Sec	WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.					

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